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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori et al.

Art Unit : 2811

Serial No. : 10/623,581

Examiner : Isaac, Stanetta D

Filed : July 22, 2003

Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF  
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM  
TRANSISTOR

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

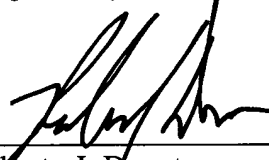
PETITION FOR ONE-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated February 9, 2005, be extended for one month to and including June 9, 2005.

Enclosed is a check for \$120 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 6/9/05

  
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Roberto J. Devoto  
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